Jaroslav Bruncko

List of Publications by Year in descending order

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1478280 1474057 19 94 9 6 citations h-index g-index papers 19 19 19 192 docs citations times ranked citing authors all docs

| # | Article | IF | CITATIONS |
|----|---|-----|-----------|
| 1 | Electrical and optical properties of thin ZnO shell layers on GaP nanorods grown by pulsed laser deposition. Thin Solid Films, 2021, 725, 138634. | 0.8 | 3 |
| 2 | Influence of boron doped diamond electrodes properties on the elimination of selected pharmaceuticals from wastewater. Journal of Electroanalytical Chemistry, 2020, 862, 114007. | 1.9 | 8 |
| 3 | A low-temperature limit for growth of ZnO nanowires by using of laser ablation processes. Applied Physics A: Materials Science and Processing, 2020, 126, 1. | 1.1 | 5 |
| 4 | Pulsed laser deposition of Ga doped ZnO films - Influence of deposition temperature and laser pulse frequency on structural, optical and electrical properties. Vacuum, 2019, 159, 134-140. | 1.6 | 21 |
| 5 | Comparative study of ZnO thin film prepared by pulsed laser deposition – Comparison of influence of different ablative lasers. Vacuum, 2017, 138, 184-190. | 1.6 | 9 |
| 6 | Fabrication and Characterization of N-Type Zinc Oxide/P-Type Boron Doped Diamond Heterojunction. Journal of Electrical Engineering, 2015, 66, 277-281. | 0.4 | 3 |
| 7 | Surface morphology study of recrystallization dynamics of amorphous ZnO layers prepared on different substrates. Applied Physics A: Materials Science and Processing, 2014, 117, 1353-1358. | 1.1 | 1 |
| 8 | Pulsed laser deposition of thin films on actively cooled substrates. Vacuum, 2013, 98, 56-62. | 1.6 | 6 |
| 9 | In-process ZnO thin films alloying during pulsed laser deposition. Applied Physics A: Materials Science and Processing, 2013, 110, 877-882. | 1.1 | 1 |
| 10 | Cryogenic pulsed laser deposition of ZnO. Vacuum, 2012, 86, 684-688. | 1.6 | 3 |
| 11 | Pulsed laser deposition of ZnO in N2O atmosphere. Applied Physics A: Materials Science and Processing, 2010, 101, 665-669. | 1.1 | 1 |
| 12 | Study of ZnO layers growth by pulsed laser deposition from Zn and ZnO targets. Vacuum, 2009, 84, 162-165. | 1.6 | 11 |
| 13 | AFM surface analysis of ZnO layers prepared by pulsed laser deposition at different oxygen pressures. Vacuum, 2009, 84, 166-169. | 1.6 | 12 |
| 14 | Comparative study of ZnO layers prepared by PLD from different targets at various oxygen pressure levels. Open Physics, 2009, 7, . | 0.8 | 3 |
| 15 | Growth and characterization of pulsed laser deposited ZnO thin films. Open Physics, 2007, 5, . | 0.8 | 5 |
| 16 | Pulsed laser deposition of ZnO: comparison between deposition from Zn and ZnO target., 2004,,. | | 0 |
| 17 | Comparison of growth rate, roughness, and surface morphology of Cu and W thin films prepared by pulsed laser deposition., 2004, 5449, 57. | | 0 |
| 18 | Monitoring of laser welding process by optical emission spectroscopy. , 2003, 5036, 57. | | 2 |

| # | Article | IF | CITATIONS |
|----|---|-----|-----------|
| 19 | Hybrid welding of duplex steels for chemical vessels. Monatshefte Für Chemie, 0, , 1. | 0.9 | O |